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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Han et al.

Attorney Docket No.: KLA1P058/P880

Application No.: 10/058,614

Examiner: Nguyen, Vinh P.

Filed: January 28, 2002

Group: 2829

Title: **ELECTRON BEAM INSPECTION SYSTEM
USING MULTIPLE ELECTRON BEAMS AND
UNIFORM FOCUS AND DEFLECTION MECHANISMS**

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on July 23, 2003 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: *Leslie Russell*
Leslie Russell

AMENDMENT TRANSMITTAL

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	17	MINUS	20	0	x 9 =	x 18 = 0.00
Independent Claims	3	MINUS	3	0	x 42 =	x 84 = 0.00
Multiple Dependent Claim Present and Fee Not Previously Paid					\$140.00	\$280.00
Total					\$	\$0.00

☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.

☒ Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. KLA1P058).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLP

Phillip P. Lee
Phillip P. Lee
Reg. No. 46,8666

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Berkeley, CA 94704-0778



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PATENT

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I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Arlington, VA 22313-1450 on July 23, 2003.

Signed: _____

Leslie Russell

AMENDMENT A

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Arlington, VA 22313-1450

Sir:

Please consider the following amendments and remarks in response to the Office Action mailed on April 23, 2003. Amendments to the Claims are reflected in the listing of the claims commencing on page 2. Amendments to the Specification are reflected on page 5 of this paper. Remarks and arguments begin on page 6 of this paper.

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